



1763
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Bailey III et al.

Attorney Docket No.: LAM1P123

Application No.: 09/470,236

Examiner: Alejandro Mulero, Luz L.

Filed: November 15, 1999

Group: 1763

Title: PLASMA PROCESSING SYSTEM WITH
DYNAMIC GAS DISTRIBUTION CONTROL

Confirmation No.: 5922

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on March 30, 2007 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

Signed:


Lara M. Nelson

**INFORMATION DISCLOSURE STATEMENT
IN RESPONSE TO CORRESPONDING FOREIGN SEARCH REPORT OR
FOREIGN OFFICE ACTION**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The reference(s) identified in the attached PTO Form 1449 (copies of non-U.S. references are attached) may be material to the examination of the above-identified patent application. These reference(s) were cited in a related Chinese application. A copy of the Chinese Office Action which was dated February 16, 2007 is enclosed herewith. These reference(s) are identified in compliance with the applicant's duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. Accordingly, the Examiner is requested to make the identified reference(s) of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that additional information (material to the examination of this application) does not exist or that the identified reference(s) constitute prior art.

Statement under 37 CFR § 1.97(e)

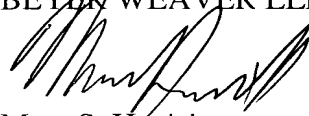
The undersigned hereby states that the reference(s) identified herewith were first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement. (37 CFR 1.97(e)(1))

Authorization for Deposit Account

In view of the foregoing, it is respectfully submitted that no fee is due in conjunction with the filing of this Information Disclosure Statement. However, should the Commissioner determine that additional fees are required for filing the present Information Disclosure Statement, the Commissioner is hereby authorized to charge any such fees to our Deposit Account Number 50-0388 (Order No. LAM1P123).

Respectfully submitted,

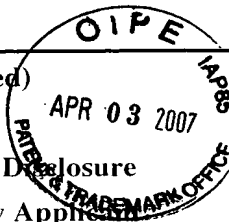
BEYER WEAVER LLP



Marc S. Hanish

Registration No. 42,626

P.O. Box 70250
Oakland, CA 94612-0250

Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)		Atty Docket No.	LAM1P123
		Application No.:	09/470,236
		Applicant	Bailey III et al.
		Filing Date	November 15, 1999
		Group	1763
			Page 1 of 1

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A.						
	B.						
	C.						
	D.						

Foreign Patent or Published Foreign Patent Application

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	Translation	
							Yes	No
	E.	EP 0 786 794 B1	7/2/03	EPO				

Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
	F.	Chinese Office Action dated February 16, 2007 from related Chinese Application No. 200510103661.8 (English Translation enclosed)
	G.	
	H.	
	I.	
	J.	
	K.	
	L.	
	M.	
	N.	
	O.	
	P.	
	Q.	
	R.	

Examiner	Date Considered
----------	-----------------

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.